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Substitute for form 1449B/PTO				Complete If Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	Unassigned
Date Submitted: August 8, 2006 (use as many sheets as necessary)				Filing Date	02/02/2005
				First Named Inventor	Tadahiro OHMI
				Group Art Unit	Unassigned
				Examiner Name	Unassigned
Sheet	1	of	1	Attorney Docket Number	039262-0156

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
	A1	2006/0263487	A1	TSUCHIYA	12-01-2005	2005 0263487
	A2	6,204,193	B1	JOZAKI	03-20-2001	

UNPUBLISHED U.S. PATENT APPLICATION DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Application Document		Name of Patentee or Applicant of Cited Document	Filing Date of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Office ³	Number ⁴ Kind Code ⁵ (if known)				
	A3	JP	2003-347281	A	SEMICONDUCTOR LEADING EDGE TEC.	12-05-2003	A
	A4	JP	2003-533042	A	TOKYO ELECTRON LTD.	11-05-2003	A
	A5	JP	2003-188155	A	TEXAS INSTRUMENTS	07-04-2003	A
	A6	JP	11-307512		SONY CORP.	11-05-1999	A
	A7	EP	1 308 994	A1	TEXAS INSTRUMENTS	05-07-2003	

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.			
		Office ³	Number ⁴	Kind Code ⁵ (if known)	
	A8	R. KAIHARA et al., "Damage-Free Contact Etching Using Balanced Electron Drift Magnetron Etcher." The Ninth International Symposium on Semiconductor Manufacturing, Proceeding of ISSM 2000, pp. 102-103.			

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.E./

Examiner Signature	/Caridad Everhart/	Date Considered	04/08/2008
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¹ Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that Issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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